L Number	Hits	Search Text	DB	Time stamp
-	30269	laser and lens and source and (target wafer sample specimen)	USPAT;	2003/11/10 14:08
			ЕРО; ЛРО;	
			DERWENT	
-	0	(laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 08:31
		energy adj desorption adj cell	ЕРО; ЛРО;	
			DERWENT	
-	1	(laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 08:31
		energy adj detection adj cell	ЕРО; ЛРО;	
			DERWENT	
_	18446	(laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 08:33
		mechan\$6	ЕРО; ЛРО;	
			DERWENT	
_	1349	((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 08:33
		mechan\$6) and pivot	ЕРО; ЛРО;	
			DERWENT	
_	790	(((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 08:43
		mechan\$6) and pivot) and ((lateral and vertical) (x and y))	ЕРО; ЛРО;	
		(interest and private and (interest and vertical) (it and y))	DERWENT	
_	731	(((((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 08:34
	, , , ,	mechan\$6) and pivot) and ((lateral and vertical) (x and y))) and rotat\$6	EPO; JPO;	
		(laneral alla relieva) mia pri ori mia relieval) (h alla 1))) alla reliate	DERWENT	
_	93	((((((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/10 14:08
	,,,	mechan\$6) and pivot) and ((lateral and vertical) (x and y))) and rotat\$6)	ЕРО; ЛРО;	2000,11,10 14.00
		and energy with detect\$6	DERWENT	
_	3140	(laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 08:43
	3110	((mov\$5 and mechan\$6) same source)	ЕРО; ЛРО;	2003/11/07 00.13
		((Into the and internal do) sainte source)	DERWENT	
_	1803	((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 09:21
	1005	((mov\$5 and mechan\$6) same source)) and ((lateral and vertical) (x and	EPO; JPO;	2003/11/07 07.21
		((incres and incentance) same source)) and ((increa and vertical) (x and y))	DERWENT	
_	853	(((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 08:44
	055	((mov\$5 and mechan\$6) same source)) and ((lateral and vertical) (x and	ЕРО; ЛРО;	2003/11/07 00.44
		y))) and rotat\$6 same source	DERWENT	
_	200	((((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 09:17
	200	(((mov\$5 and mechan\$6) same source)) and ((lateral and vertical) (x and	ЕРО; ЛРО;	2003/11/07 07:17
		y))) and rotat\$6 same source) and 250/\$.ccls.	DERWENT	
_	1996	(pivot\$5 and rotat\$5 and mov\$6) same laser	USPAT;	2003/11/07 13:38
	1,,,,	(proofs and roads and more) same racer	ЕРО; ЛРО;	2000,11,0, 10,00
			DERWENT	
_	858	((pivot\$5 and rotat\$5 and mov\$6) same laser) and (optic\$5 lens) and	USPAT;	2003/11/07 09:18
		(target wafer sample specimen substrate)	ЕРО; ЈРО;	
		() () () () () () () () () ()	DERWENT	
_	849	((pivot\$5 and rotat\$5 and mov\$6) same laser) and ((lateral and vertical)	USPAT;	2003/11/07 09:21
		(x and y))	ЕРО; ЛРО;	
			DERWENT	
-	510	((pivot\$5 and rotat\$5 and mov\$6) same laser) and ((lateral and vertical)	USPAT;	2003/11/07 09:35
		(x and y) same source)	ЕРО; ЛРО;	
		1` ''	DERWENT	
-	328	(((pivot\$5 and rotat\$5 and mov\$6) same laser) and ((lateral and	USPAT;	2003/11/07 13:32
		vertical) (x and y) same source)) and lens	ЕРО; ЛРО;	
		, , , , , , , , , , , , , , , , , , , ,	DERWENT	
-	3	((((pivot\$5 and rotat\$5 and mov\$6) same laser) and ((lateral and	USPAT;	2003/11/07 13:34
		vertical) (x and y) same source)) and lens) and virtual adj source	ЕРО; ЛРО;	
			DERWENT	
-	1	((((pivot\$5 and rotat\$5 and mov\$6) same laser) and ((lateral and	USPAT;	2003/11/07 13:33
		vertical) (x and y) same source)) and lens) and detection adj cell	ЕРО; ЛРО;	
			DERWENT	
-	77	(laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/07 13:35
		virtual adj source	ЕРО, ЛРО,	
			DERWENT	
-	4	((pivot\$5 and rotat\$5 and mov\$6) same laser) and virtual adj source	USPAT;	2003/11/07 13:36
			ЕРО; ЈРО;	
			DERWENT	

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	0	((pivot\$5 and rotat\$5 and mov\$6) same laser) and laser adj desorption	USPAT;	2003/11/07 13:36
		adj spectrometer	ЕРО; ЛРО;	2003/11/07 13:50
		and procedure to the same to t	DERWENT	
<u>-</u>	0	laser adj desorption adj spectrometer	USPAT;	2003/11/07 13:36
		laser and description and operationeter	EPO; JPO;	2003/11/07 13:50
			DERWENT	
	372	laser adj desorption with spectrometer	USPAT:	2003/11/07 13:37
-	3/2	laser and description with spectrometer	ЕРО; ЛРО;	2003/11/07 13.37
			DERWENT	•
	6370	((pivot\$5 and rotat\$5 and mov\$6) same laser) adn (laser adj desorption	USPAT;	2003/11/07 13:37
	0570	with spectrometer)	ЕРО; ЛРО;	2003/11/07 13.37
		with spectrometer)	DERWENT	
	1	((pivot\$5 and rotat\$5 and mov\$6) same laser) and (laser adj desorption	USPAT;	2003/11/07 13:37
}	1	with spectrometer)	ЕРО; ЛРО;	2003/11/07 13.37
		with spectrometer)	DERWENT	
	8	(laser and (target wafer substrate specimen sample) and detection adj	USPAT;	2003/11/07 13:41
-	•	cell and lens) and virtual	ЕРО; ЛРО;	2003/11/07 13.41
		cen and lens) and virtual	DERWENT	
	1	(laser and (target wafer substrate specimen sample) and detection adj	USPAT;	2003/11/07 13:41
-	1	cell and lens) and virtual adj source	ЕРО; ЛРО;	2003/11/07 13.41
		cen and lens) and virtual adj source	DERWENT	
	154	laser and (target wafer substrate specimen sample) and detection adj cell	l .	2002/11/07 14:20
-	134	and lens	USPAT; EPO; JPO;	2003/11/07 14:29
		and lens	DERWENT	
	400	laser and lens and source and (target wafer sample specimen) and	USPAT;	2003/11/10 14:08
-	400	gimbal	ЕРО; ЛРО;	2003/11/10 14.08
		ginioai	DERWENT	
_	4	((((((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/10 14:27
_	_	mechan\$6) and pivot) and ((lateral and vertical) (x and y))) and rotat\$6)	ЕРО; ЛРО;	2003/11/10 14.27
		and energy with detect\$6 and gimbal	DERWENT	
_	93	(((((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/10 14:32
	, , ,	mechan\$6) and pivot) and ((lateral and vertical) (x and y))) and rotat\$6)	ЕРО; ЛРО;	2003/11/10 11:32
		and energy with detect\$6	DERWENT	
_	2	((((((laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/10 14:29
	_	mechan\$6) and pivot) and ((lateral and vertical) (x and y))) and rotat\$6)	ЕРО; ЛРО;	
		and energy with detect\$6) and detection adj cell	DERWENT	
-	71	(laser and lens and source and (target wafer sample specimen)) and	USPAT;	2003/11/10 14:33
		energy and detection adj cell	ЕРО; ЛРО;	
1			DERWENT	
-	2	mechanical adj resolution and spatial adj resolution	USPAT;	2004/04/16 08:55
			ЕРО; ЛРО;	
			DERWENT	
-	17	peaucellier	USPAT;	2004/04/16 09:48
<u> </u>	;		ЕРО, ЈРО,	
			DERWENT	